NIN THE UNITED STATE	S PATENT A	AND TRADEMAI	RK OFFICE	> 5	814
In re Patent Application of O	ktty Dkt. 1035 C#	-243 M#	•	i ·	· F
SASAKI AU6 2 1 2003 µ Group Art	t Unit: 2814				•
Serial No. 09/487,259 Exa	ıminer: A. Ma	ai			
Filed: January 19, 2000 Thenewhere	Date: Augu	st 21, 2003			
Title: METHOD OF MANUFACTURING SEMICONDUC ETCHING	TOR DEVICE	USING CHEMICA	L		
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450					
Sir:					
This is a response/amendment/letter in the above-ide incorporated by reference and the signature below se signature thereon.	ntified applica				
	Form Attac	hed.			
Fees are attached as calculated below: Total effective claims after amendment 48 min previously paid for 42 (at least 20) = 6	nus highest n x \$	umber 18.00		\$	108.00
Independent claims after amendment 6 mir previously paid for 5 (at least 3) = 1	nus highest n x \$	umber 84.00		\$	84.00
If proper multiple dependent claims now added for firs	st time, add \$2	280.00 (ignore in	nproper)	\$	0.00
Petition is hereby made to extend the current due date paper and attachment(s) (\$110.00/1 month; \$410.00/2 month)	e so as to cov	er the filing date		\$	0.00
Terminal disclaimer enclosed, add \$ 110.00		,		\$	0.00
☐ First/second submission after Final Rejection purs ☐ Please enter the previously unentered , ☐ Submission attached	suant to 37 C , filed	FR 1.129(a) (\$75	50.00)	\$	0.00
			Subtotal	\$	192.00
If "small entity," then enter half (1/2) of subtotal and su  Applicant claims "small entity" status.		filed herewith		-\$	0.00
Rule 56 Information Disclosure Statement Filing Fee (	(\$180.00)			\$	0.00
Assignment Recording Fee (\$40.00)				\$	0.00
Other:					0.00
		т	OTAL FEE ENCLOSED	s	192.00
The Commissioner is hereby authorized to charge any asserted to be filed, or which should have been filed h firm) to our Account No. 14-1140. A duplicate copy of	nerewith (or w	or credit any ove ith any paper he	rpayment, in the fee(s) fi	led, or	
1100 North Glebe Road, 8 <sup>th</sup> Floor Arlington, Virginia 22201-4714 Telephone: (703) 816-4000 Facsimile: (703) 816-4100	By Atty: Mic	NDERHYE P.C. hael J. Shea, Re	eg. No. 34,725	7 <b>0</b> •	<b>31</b>
MJS:dbp	Signature: 2	<u>Hucktrik</u>	Chi Chite 2800	UB 26 2003	RECEIVED

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application:

**SASAKI** 

Atty. Ref.:

1035-243

Serial No.:

09/487,259

Group:

2814

Filed:

January 19, 2000

Examiner:

A. Mai

For:

METHOD FOR MANUFACTURING A SEMICONDUCTOR

DEVICE USING CHEMICAL ETCHING

\*\*\*\*\*\*\*

August 21, 2003

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT**

Sir:

In response to the office action dated May 21, 2003, please amend the subject patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

An Amendment to the Title is reflected on page 14 of this paper.

**Remarks** begin on page 15 of this paper.

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01 FC:1201 02 FC:1202 84.00 OP 108.00 OP